

# Thermodynamic Induction and its Applications

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# Approach to Equilibrium

- For any of  $n$  variables:

$$\langle \dot{a}_i(t') \rangle = \left\langle \dot{a}_i(t') e^{\frac{\Delta S_T(t'-t)}{k_B}} \right\rangle_0$$

- This is our basic assumption.
  - short-time limit of fluctuation theorem
- replace nonequilibrium averaging with (weighted) averaging over equilibrium states
- If generalized forces defined by

$$X_i = \frac{\partial \Delta S_T}{\partial a_i}$$

then

$$\Delta S_T = \sum_{j=1}^n X_j \Delta a_j$$

Onsager PR (1931);  
Evans & Searles, Adv Phys (2002);  
Patitsas Am J Phys (2014)

# Variable Kinetic Coefficients (VKC)

- If  $\sigma_T$  is the total rate of entropy production, then

$$\sigma_T = \sum_{j=1}^n X_j \dot{a}_j$$

and

$$\Delta S_T = \int_t^{t+\Delta t_i} \sigma_T dt''$$

- Now focus on nonlinear part of  $\sigma_T$

$$M_{ij} = L_{ij} + \sum_l \gamma_{ij,l} a_l \qquad \gamma_{ij,l} = \left( \frac{\partial M_{ij}}{\partial a_l} \right)_{a_l=0}$$

$$\sigma_{nonlin} = \sum_{i=1}^m \sum_{j=1}^m \sum_{l=m+1}^n \gamma_{ij,l} X_i X_j a_l$$

# Induction Terms

- after some algebra, TI terms produced:

$$\dot{a}_p = \sum_{q=1}^n (L_{pq} + N_{pq})X_q$$

where

$$\tau_k N_{ki} = -\tau_k^* N_{ik} \quad N_{ik} = -L_{kk} \tau_k \sum_{j=1}^m \gamma_{ij,l} X_j, \quad i \leq m, k > m$$

$\tau_k^*$  are time scales for fluctuations (very small)

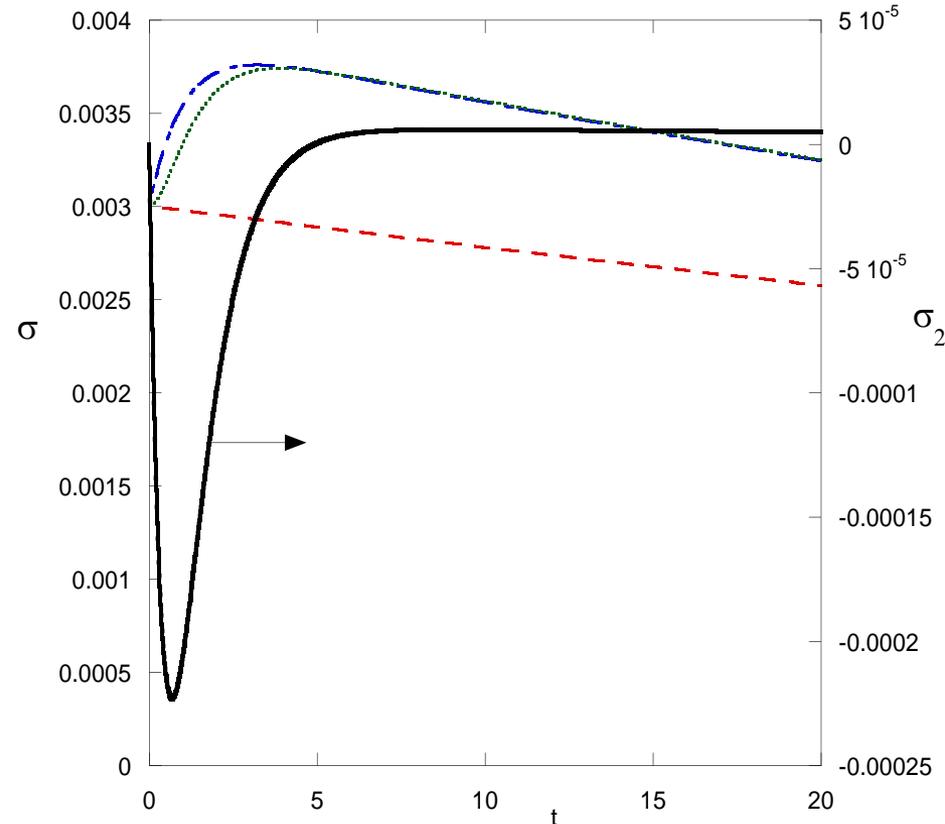
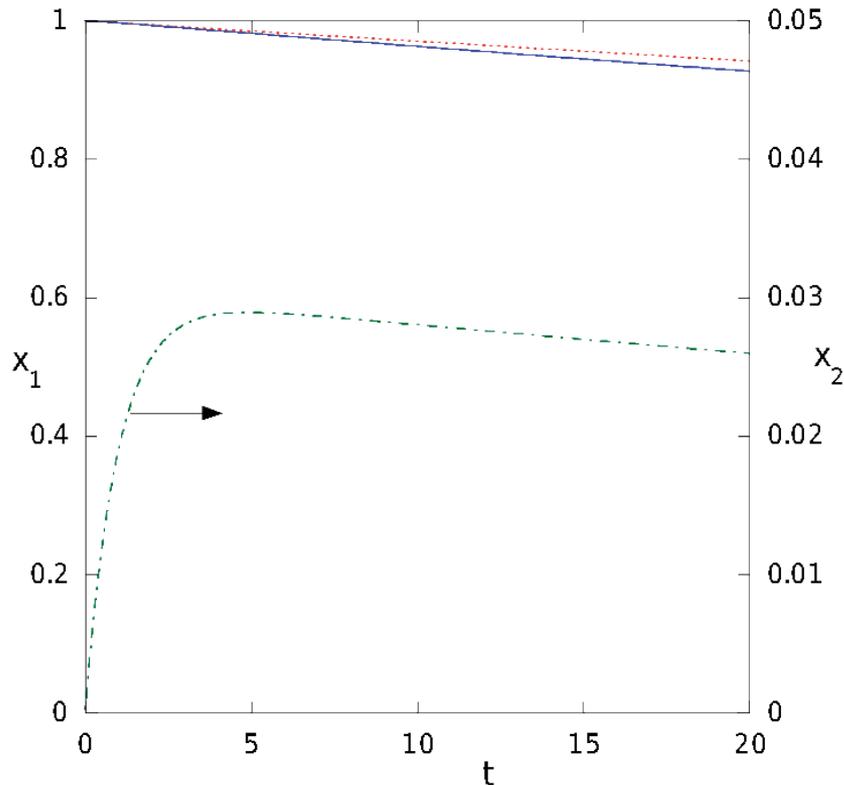
$\tau_k$  are relaxation times (larger than  $\tau_k^*$ )

# Two Variable Case

- going back to the case of 2 variables, one slow, one fast:

$$\dot{a}_1 = L_{11}X_1 - [\gamma_{11,2}g_{22}^{-1}X_1] X_2$$

$$\dot{a}_2 = + [r_2\gamma_{11,2}g_{22}^{-1}X_1] X_1 + L_{22}X_2$$



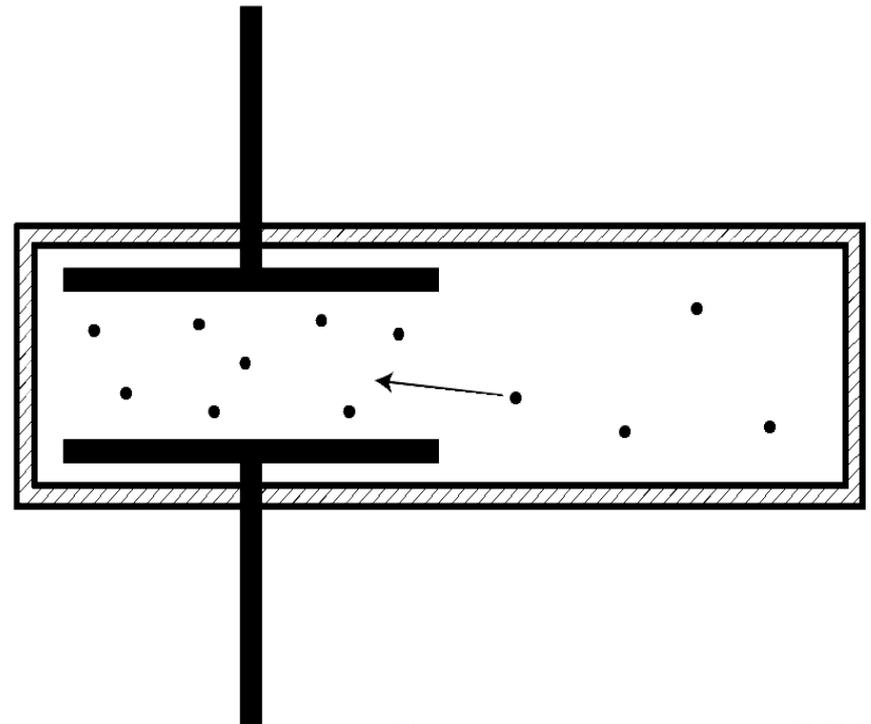
# Isothermal Particle Flow

- TI analysis can also be done under isothermal conditions
  - use  $\Delta F$  instead of  $\Delta S$
  - ideal for studying particle transport
    - variable 1 (DR) - electrical conduction
    - variable 2 (G) – diffusion
- power running through circuit is  $P_0$
- timescale for fluctuations is  $\tau_G^*$
- dimensionless parameter:

$$\kappa \equiv \frac{\bar{N}_2 \gamma}{L_{11}}$$

- key results for SS:

$$\Delta\mu_G = \frac{\kappa P_0 \tau_G^*}{\bar{N}_G}$$



# Possible Scenarios for TI: ionic solns

- H<sup>+</sup> ions in water at RT have mobility  $3.7 \times 10^{-3} \text{ cm}^2/\text{Vs}$ 
  - too small
- superfluid He II
  - ionic mobility  $\sim 10,000 \text{ cm}^2/\text{Vs}$
  - should observe  $\Delta\mu_G = 10^{-3} \text{ eV}$  at  $E = 1 \text{ V/cm}$
- silicon at RT:
  - electron mobility =  $1400 \text{ cm}^2/\text{Vs}$
  - $\Delta\mu_G = kT$  at  $E = 4300 \text{ V/cm}$
  - carriers would tend to accumulate in potential wells
    - look for enhanced conductance and possible runaway

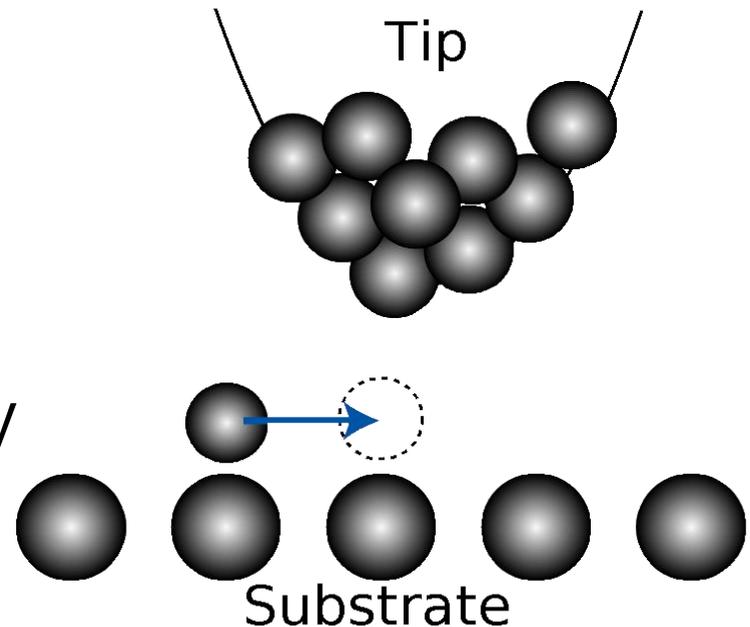
# Effects of STM on Surface Diffusion

- STM tunnel junction described by conductance  $G$
- $G = G_0 \exp(-\alpha r)$  where  $r$  is tip-sample distance
  - $\alpha \sim 22 \text{ nm}^{-1}$
- $G$  changes when adsorbate directly under tip
  - $dG/dN_2$  can be positive or negative in STM
  - apparent height  $a$

$$\Delta\mu_{ads} = P_0 \tau^* \alpha a$$

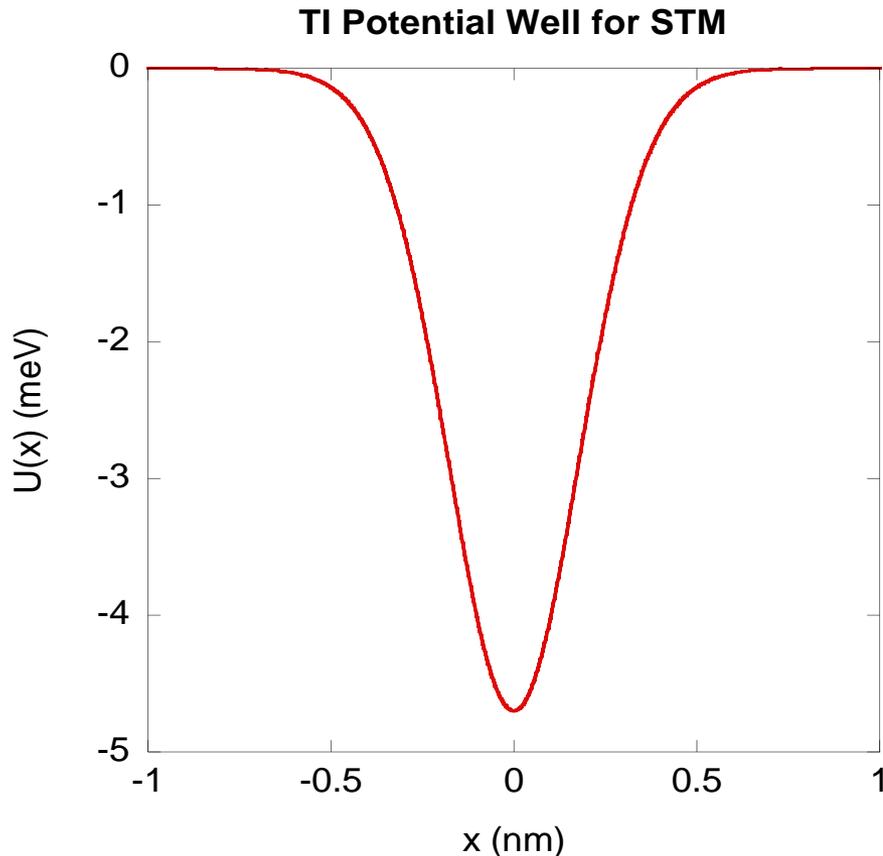
(depth of potential well)

- typical numbers, 100 pA, 0.1 V
  - with  $a=0.1 \text{ nm}$ ,  $\Delta\mu_{ads} = 0.014 \text{ meV}$
  - negligible effect (check)
  - with 40 nA, 0.5 V,  $\Delta\mu_{ads} = 28 \text{ meV}$
  - strong effect on occupancy



# TI and STM-Based Manipulations

- literature review and interpretation in terms of TI
  - Xe/Ni(110) at 4 K
  - $a = +0.16$  nm
  - sliding-type manipulation at 4.8 M $\Omega$  junc. imped.
  - manipulation attributed to vibrational excitation by STM



- TI calc:
- $\Delta\mu_{\text{ads}} = 4.7$  meV = 10 kT
- provides potential well to trap Xe
- TI works in concert with vibr. excit.

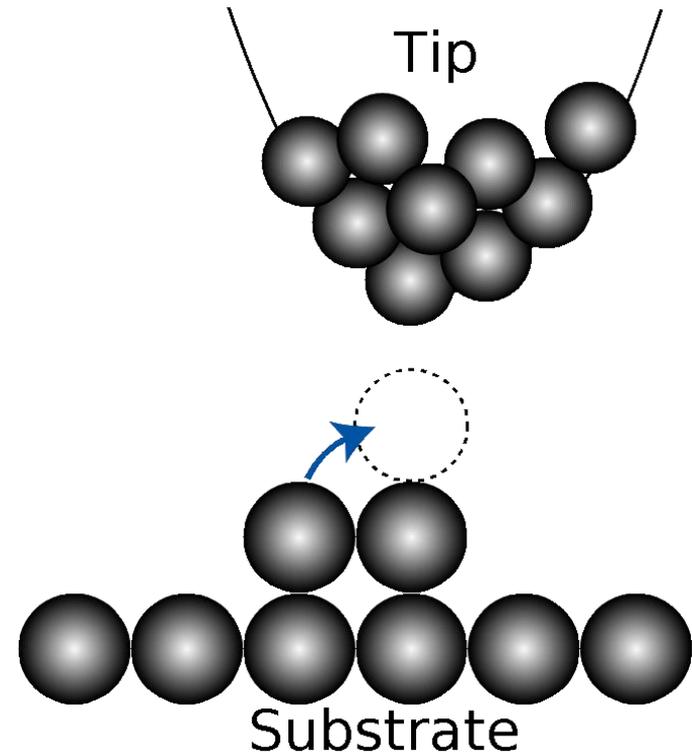
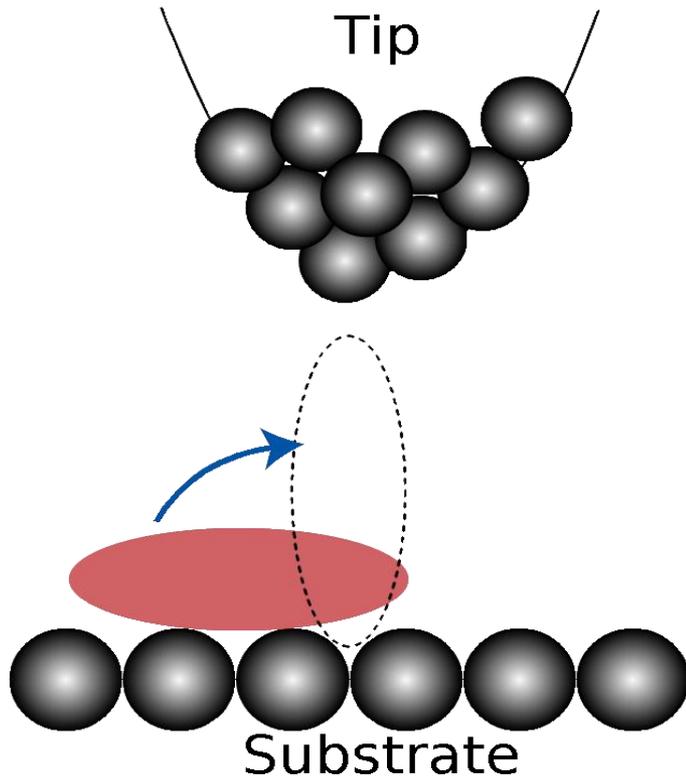
Zeppenfeld, Lutz, Eigler, Ultramic. ('92)  
Lyo & Avouris, Sci ('91)

# Molecule Sliding vs. Pushing

- further literature review and interpretation in terms of TI
- CO/Pt(111) at 4 K
  - $a = +0.05$  nm
  - sliding-type manipulation at 300 k $\Omega$  junc. imped.
  - TI calc:  $\Delta\mu_{\text{ads}} = 30$  meV (potential well)
- in stark contrast for a very similar system:
  - CO/Cu(211)
    - $a = -0.06$  nm
    - sliding-type manipulations do not work
    - only pushing works along step edges, at 390 k $\Omega$  junc. imped.
    - TI calc:  $\Delta\mu_{\text{ads}} = -32$  meV (potential barrier)
    - no accepted mechanism explains this!

# Further Proposals Using STM

- On-top process possible if tip pulled back to make room



# Conclusions

- Onsager symmetry extended to nonlinear realm
  - new terms in dynamical equations (TI)
- dynamical reservoir variables induce gate variables to move away from equilibrium
- principle of maximum entropy production (with cont. limit)
- proposals for induced ionic diffusion seem feasible
  - possible applications to semiconductor device fabrication
- TI produces potential wells for trapping adsorbates with STM tip
  - potential barriers in some cases
  - TI provides general structure for specific mechanisms
    - vibrational excit., temp. ion reson., electronic excit. etc.

# Further Proposals Using STM

- atomic tether

